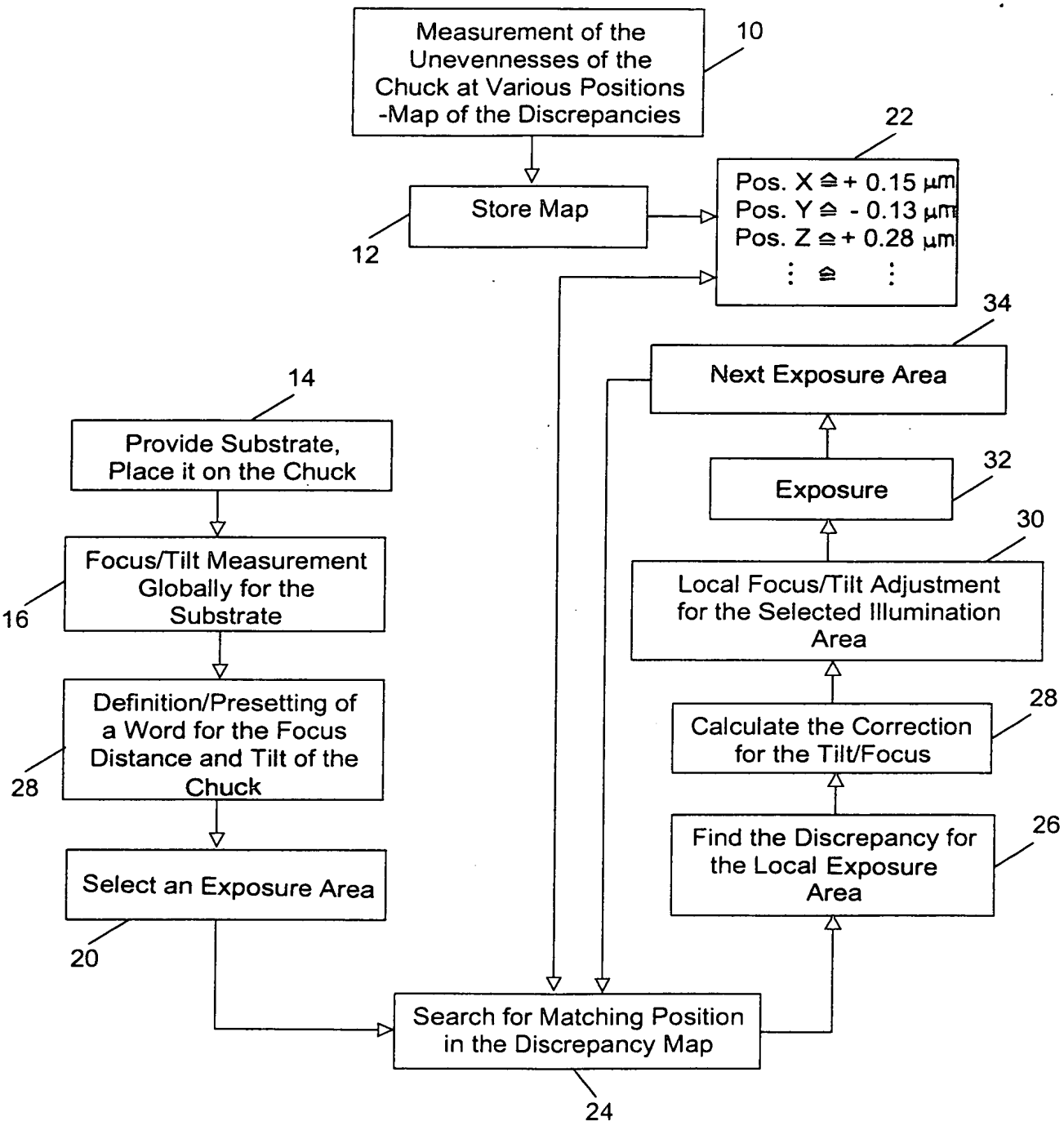
Measurement of the Unevennesses of the Chuck at Various Positions -Map of the Discrepancies
10
Store Map
12
22
Pos. X ≙ + 0.15 µm
Pos. Y ≙ - 0.13 µm
Pos. Z ≙ + 0.28 µm
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Next Exposure Area
32
Exposure
30
Local Focus/Tilt Adjustment for the Selected Illumination Area
28
Calculate the Correction for the Tilt/Focus
26
Find the Discrepancy for the Local Exposure Area
14
Provide Substrate, Place it on the Chuck
16
Focus/Tilt Measurement Globally for the Substrate
28
Definition/Presetting of a Word for the Focus Distance and Tilt of the Chuck
20
Select an Exposure Area
24
Search for Matching Position in the Discrepancy Map